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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)	
Shang-hyeun Park et al.	)	Group Art Unit: 2879
Application No.: 10/743,791	)	Examiner: SIKHA ROY
Filed: December 24, 2003	)	Confirmation No.: 9820
For: FIELD EMISSION DISPLAY AND	)	
METHOD OF MANUFACTURING THE	)	
SAME	)	

**THIRD REQUEST FOR OFFICIAL FILING RECEIPT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

An Official Filing Receipt has not been received for the above-identified application. It is respectfully requested that the U.S. Patent and Trademark Office forward the Official Filing Receipt to the undersigned.

Respectfully submitted,

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Date: January 04, 2004

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